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Application/Control No.	Applicant(s)/Patent under Reexamination
10/035,306	CHAKRAVARTI ET AL.
Examiner	Art Unit
Yemane M. Gerezgiher	2144

	SEAR	CHED	
Class	Subclass	Date	Examiner
709	223,224	10/17/2005	YMG
714	04,47	10/17/2005	YMG

INT	INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner	
709	224	10/26/2005	YMG	
709	223	10/26/2005	YMG	
			:	

SEARCH NO (INCLUDING SEARCH)
	DATE	EXMR
Updated East search (US-PGPUB; USPAT; EPO; JPO; DERWENT)	10/17/2005	
NPL search (CiteSeer + IEEE)	10/20/2005	YMG